

Sheet 1 of 1Form PTO-1449
(REV. 8-83)US Dept. of Commerce
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INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT
Eiji NATORIFILING DATE
March 29, 2001GROUP
2822

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
MG	5,753,320	5/1998	Mikoshiba et al.		
MG	5,803,974	9/1998	Mikoshiba et al.		
MC	4,668,337	9/1987	Sekine et al.		
MC	5,527,731	6/1996	Yamamoto et al.		

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

MC	Shimizu, Masaru; "Effects of O ₃ on Growth and Electrical Properties of Pb(Zr, Ti)O ₃ Thin Films by Photoenhanced Metalorganic Chemical Vapor Deposition; Department of Electronics, Kyoto University; September, 1994; pp. 5135-5138.

EXAMINER

Myra Guerrero

DATE CONSIDERED

6-30-03

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: March 24, 2003